Docket: 03680036AA (OSP-27553) S.N. 10/575.785

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Kensuke Takahashi et al.

Confirmation No. 3566

Serial No. 10/575,785

Group Art Unit 2813

Filed April 14, 2006

Examiner Stephen Smoot

For SEMICONDUCTOR DEVICE WITH SILICIDE-CONTAINING GATE ELECTRODE AND METHOD FOR FARRICATING SAME

Box Non-Fee Amendment Commissioner for Patents PO Box 1450 Alexandria, Virginia 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111, RE-SUBMISSION OF SUBSTITUTE SPECIFICATION, AND SUBMISSION OF ENGLISH TRANSLATION OF PRIORITY DOCUMENT WITH DECLARATION BY TRANSLATOR

Sir:

In response to the Office Action mailed January 28, 2009 please amend the above-identified patent application as follows:

Amendments to the Specification: Attached to the end of this amendment is an annotated copy of the specification and a clean copy of the specification which implements the annotations with a statement under 37 C.F.R. §1.125(b)(1) indicating that no new matter was included.

Amendments to the Claims: Amendments to the claims are indicated by the notation "currently amended" in the listing of claims beginning on page 2 of this paper.

Remarks: The "REMARKS" section begins on page 13 of this paper.